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Applicants: Dan A. Steinberg and Jasean Rasnake
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CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on:

By:

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Date

Assistant Commissioner for Patents
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ASSOCIATE POWER OF ATTORNEY

Dear Sir:

The following is hereby appointed Associate Attorney with full power to prosecute this application, to make alterations and amendments therein, to receive the patent and to transact all business in the Patent and Trademark Office pertaining thereto:

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Respectfully submitted,

Dated: _____

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